Remaintable: 06/10/2008

10531763 - GALSBIRS (958)
Approved for use through 06/30/2008, OMB 0651-0331
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Doc description: Information Disclosure Statement (IDS) Filed Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number

INFORMATION DISCLO	SURE
STATEMENT BY APPLIC	CANT

(Not for submission under 37 CFR 1.99)

Application Number		10531763
Filing Date		2005-04-18
First Named Inventor	Susar	n D. Strothers
Art Unit		Unknow
Examiner Name	Unkno	own
Attorney Docket Numb	er	H0004599.69957 US -4015

Cite No	Patent Number 6689254 5409590	Kind Code ¹	Issue Date 2004-02-10	Name of Patentee or Applicant of cited Document Tokyo Electron Limited	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
		B1	2004-02-10	Tokyo Electron Limited	Claime 1 2 15 17 10 27 22 41
2	5400500		1		Olaino 1, 2, 10, 17, 18, 27, 32, 41
	0409090	A	1995-04-25	Tokyo Electron Limited	Claims 1 and 3
3	5130005	A	1992-07-14	Tokyo Electron Limited	Claims 1, 6, 11, 15, 18, 21
١	6340415	B1	2002-01-22	Applied Materials, Inc.	Claim 1, 21, 26, 28
5	6955852	B2	2005-10-18	Tosoh SMD, Inc.	Claims 1, 2, 3
3	6840427	B2	2005-01-11	Tosoh SMD, Inc.	Claims 1 and 14
,	5487822	A	1996-01-30	Applied Materials, Inc.	All Claims
3	5565071	A	1996-10-15	Applied Materials, Inc.	Claim, 1 and 9
5		6340415 6955852 6840427 5487822	6340415 B1 6955852 B2 6840427 B2 5487822 A	6340415 B1 2002-01-22 6955852 B2 2005-10-18 6840427 B2 2005-01-11 5487822 A 1996-01-30	6340415 B1 2002-01-22 Applied Materials, Inc. 6955852 B2 2005-10-18 Tosoh SMD, Inc. 6840427 B2 2005-01-11 Tosoh SMD, Inc. 5487822 A 1996-01-30 Applied Materials, Inc.

eceipt da	ate:	06/10/2008		Application N	umber		10531763	10531763 - GAU: 179	5	
				Filing Date	32.10		2005-04-18		-	
		TION DISCLOSU		First Named I	First Named Inventor Susar			an D. Strothers		
		NT BY APPLICA ission under 37 CFR 1		Art Unit	Art Unit			Unknow		
(NOT 101 S	SUDIII	ission under 37 CFK 1	.55)	Examiner Name Unkno			own			
				Attorney Doc	Attorney Docket Number Hoo			H0004599.69957 US -4015		
	9	5595337	A	1997-01-21	Applied M	aterials	i, Inc.	Claims 1, 2, 3		
	10	5603816	A	1997-02-18	Applied M	aterials	s, Inc.	Claim 1		
	11	5433835	A	1995-07-18	Applied M	aterials	s, Inc.	Claims 1, 14, 21	Massimilar	
	12	5676803	A	1997-10-14	Applied Ke	omatus	Technology, Inc.	Claims 1, 7, 10, 11		
	13	5863397	А	1999-01-26	Taiwan Se Manufactu			Claims 1, 5, 15	**************************************	
	14	5985115	A	1999-11-16	Novelius S	System	s, Inc.	Claims 1-4, 5-8		
If you wisl	n to a	dd additional U.S. Pater	nt citatio	n information pl	lease click	the A	dd button.	1		
			U.S.P	ATENT APPLI	CATION P	UBLIC	CATIONS			
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publication Date	Name of of cited D		tee or Applicant ent	Pages,Columns,Lines where Relevant Passages or Relev- Figures Appear		

Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear

If you wish to add additional U.S. Published Application citation information please click the Add button.

FOREIGN PATENT DOCUMENTS

		Foreign Document	Country		Publication	Name of Patentee or Applicant of cited	Pages,Columns,Lines where Relevant	T 5
Initial*	No	Number ³	Code ² į	Code ⁴	Date	Applicant of cited Document	Passages or Relevant Figures Appear	10

eceipt date: 06/10/2008	Application Number		10531763 10531763 - GAU: 179			
•	Filing Date		2005-04-18			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	First Named Inventor	First Named Inventor Susan D. Strothers				
	Art Unit		Unknow			
	Examiner Name	Unkr	known			
	Attorney Docket Number H0004599.69957 US -4015					

	1	10018858	DE		2001-10-25	Ardenne Anlagentech GmbH	Claim 1			
	2	01-132761	1Þ		1989-05-25	Fujitsu Ltd.				
If you wist	n to a	dd additional For	eign Patent Docun	nent citation	information p	lease click the Add butto	n			
			NON-PA	TENT LIT	ERATURE DO	CUMENTS				
Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.								
	1							Е		
If you wis	h to a	dd additional nor	n-patent literature o	locument ci	tation informa	tion please click the Add	button			
				EXAMINE	R SIGNATUR	RE				
Examiner	Signa	ature /Jase	on Berman/			Date Considered	12/10/2008			
						formance with MPEP 609 with next communication				

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ² For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 'Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁴ Applicant is to place a check mark here it English language translation is attached.